



1746

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicants : Sandhu et al.
Serial No. : 09/998,073
Filed : Nov. 30, 2001
Title : METHOD AND SYSTEM PROVIDING HIGH FLUX OF POINT OF USE
ACTIVATED REACTIVE SPECIES FOR SEMICONDUCTOR
PROCESSING
Docket No. : MIO 0084PA
Examiner : G. Winter
Art Unit : 1746

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Commissioner for Patents
P.O. Box 1450
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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450, on June 24, 2003.

John D. Reed

Reg. No. 46,506

AMENDMENT AND RESPONSE UNDER 37 CFR 1.111

Sir:

This paper is being filed in response to the Office Action mailed April 4, 2003, having a reply due date of July 4, 2003. Reconsideration of the present application is respectfully requested in light of the following amendment and remarks.

In accordance with the **REVISED AMENDMENT FORMAT** and waiver of 37 CFR 1.121, as promulgated by order of Stephen Kunin, Deputy Commissioner for Patent Examination Policy, on January 31, 2003, the entire set of presently pending claims has been reproduced below in the approved revised amendment format. Any amendments to the specification and drawings have also been presented in the revised format. No separate marked-up copy of the amended claims has been provided. Moreover, no new matter has been entered.